

# **Micro Electro Mechanical Systems (MEMS):**

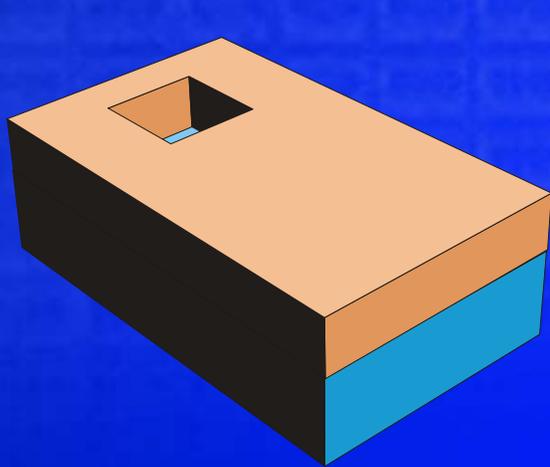
**A selective overview**

**Andrew Berlin  
Intel Corporation**

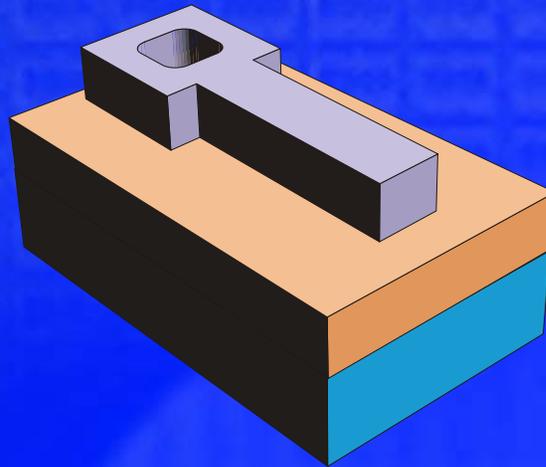
# Towards 'Proactive Computing'

- Computing everywhere and in everything
- Communications everywhere
- ...and coming soon thanks to technologies such as MEMS:
- Sensing and Actuation everywhere
  - Embedded within materials
  - Coated on surfaces
  - On and in our bodies
  - Distributed throughout the environment

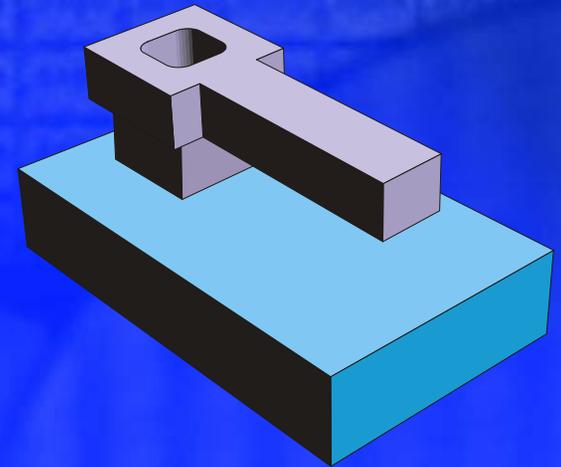
# Surface Micromachining



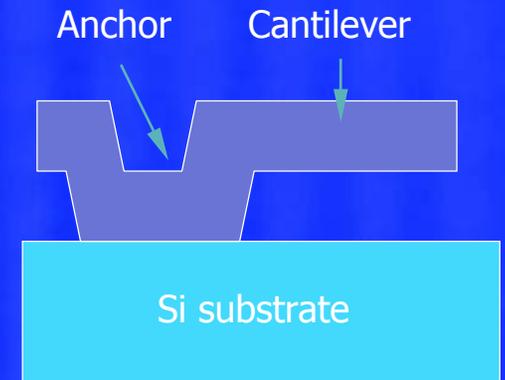
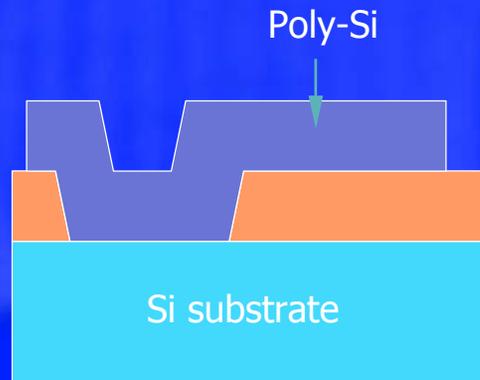
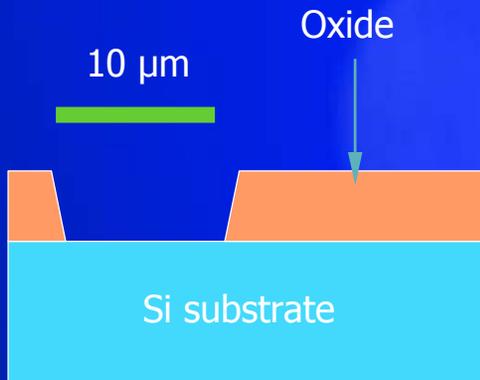
*Deposit & pattern oxide*



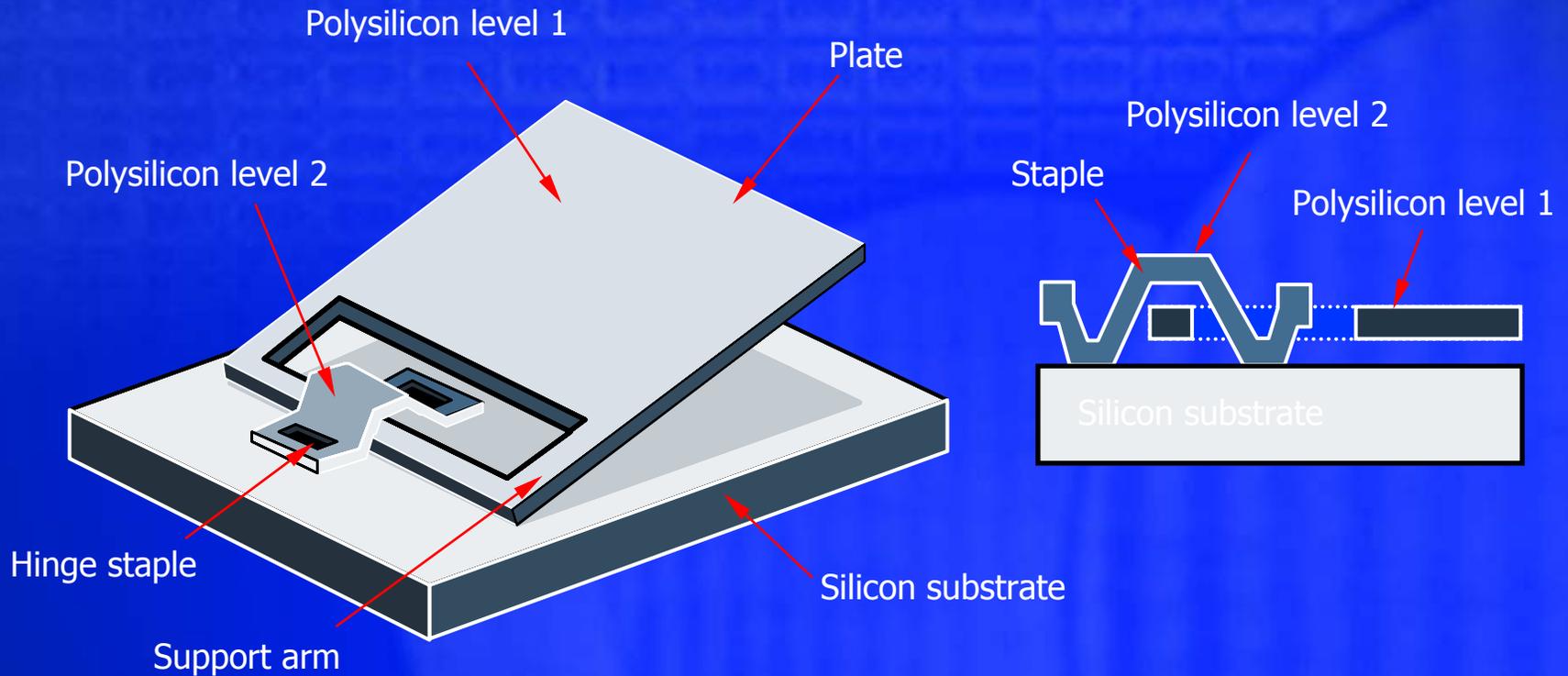
*Deposit & pattern poly*



*Sacrificial etch*



# Surface Micromachined Hinge

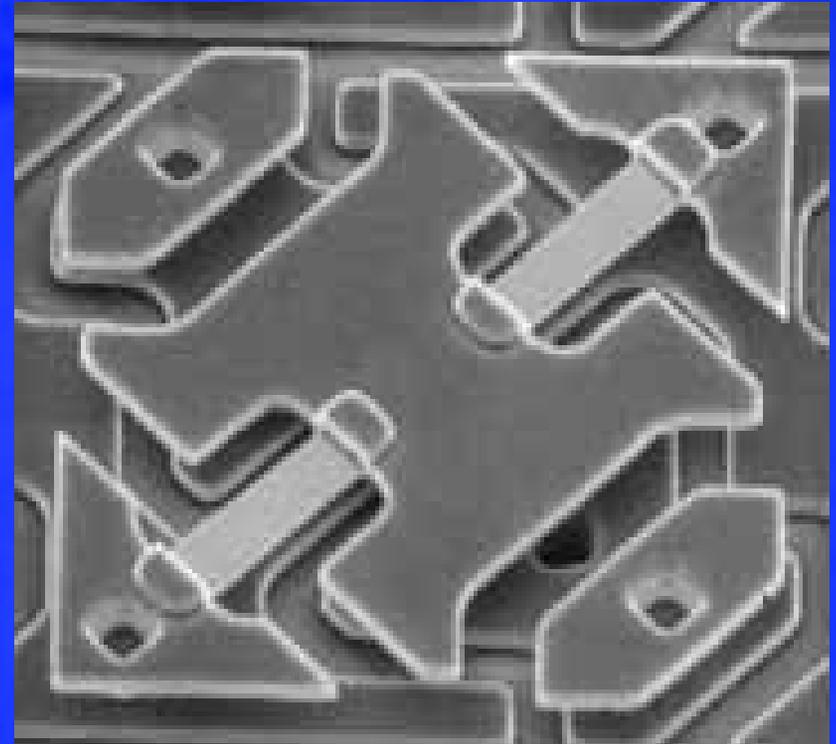
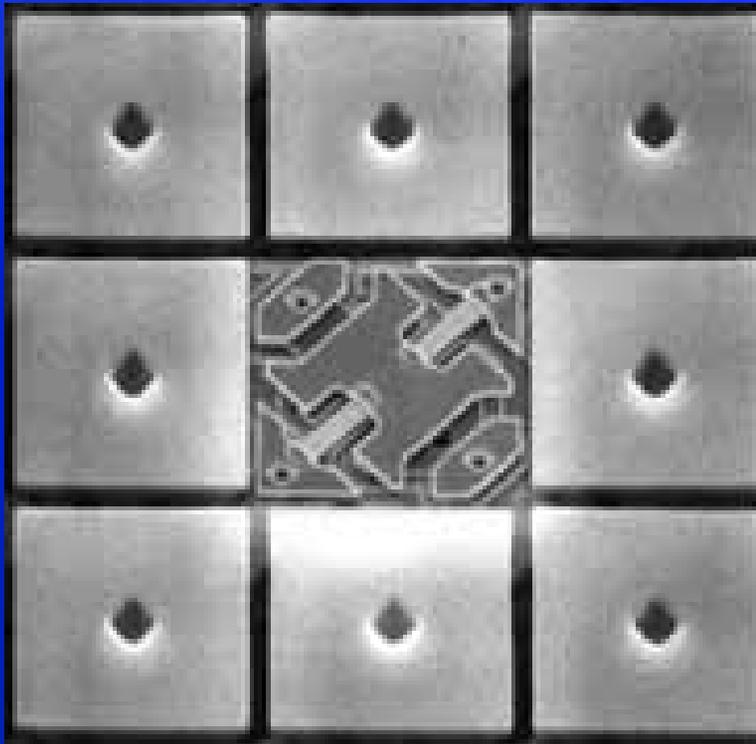


# Major MEMS application areas

- Navigation
- Industrial
- Displays
- Optical communications
- RF (MEMS Radio)
- Microbiology meets Microtechnology
- MEMS power sources

# MEMS Projection Displays

→ 17 μm ←



Texas Instruments Digital Light Projector

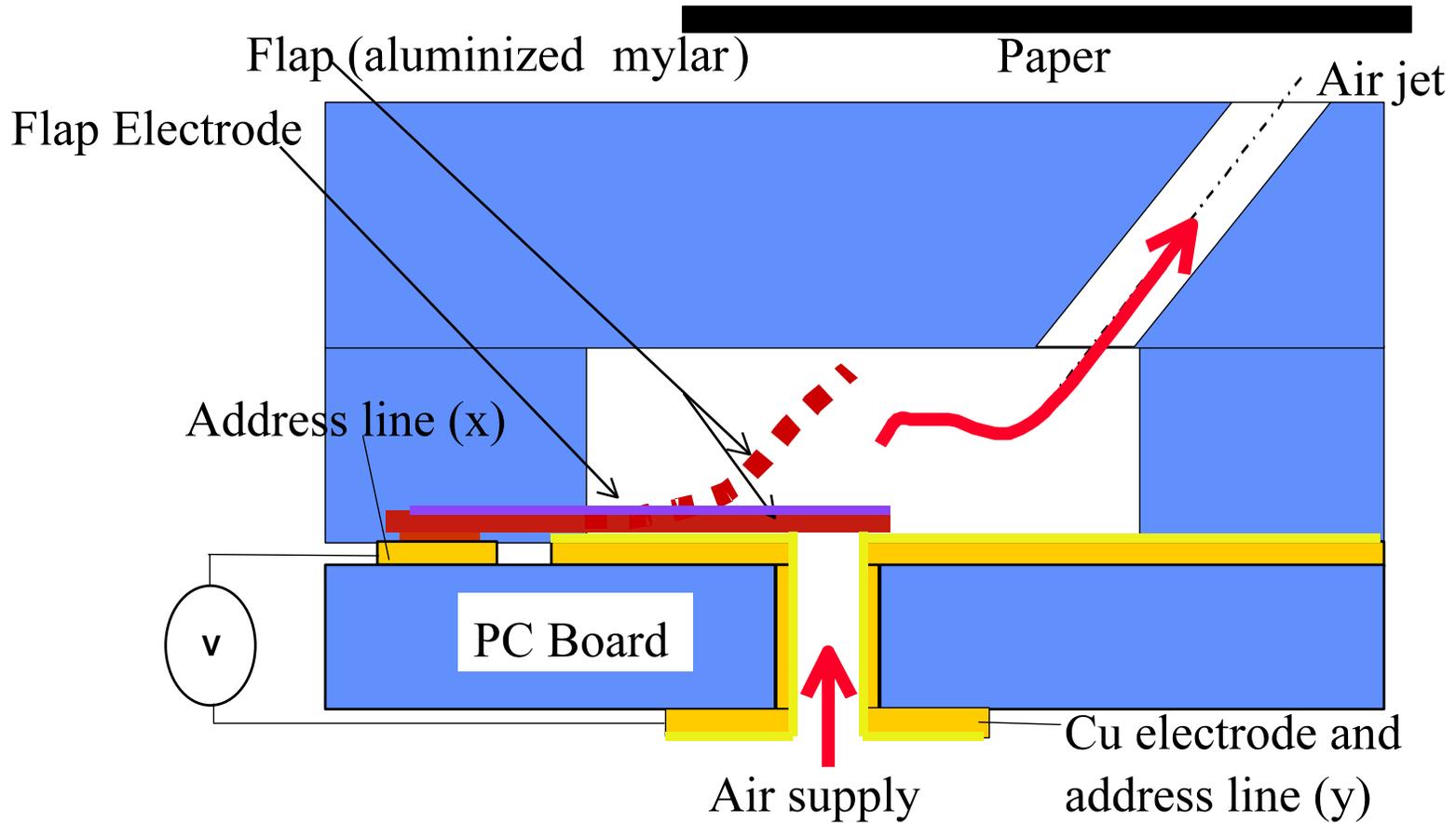


Boeing 747 :  
>50K moving parts

TI Micro-Mirror  
Display :  
> 1M moving parts



# Cantilevered valve structure



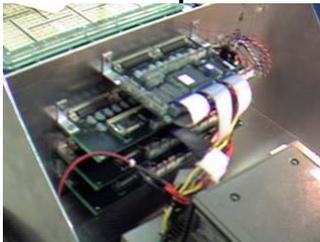
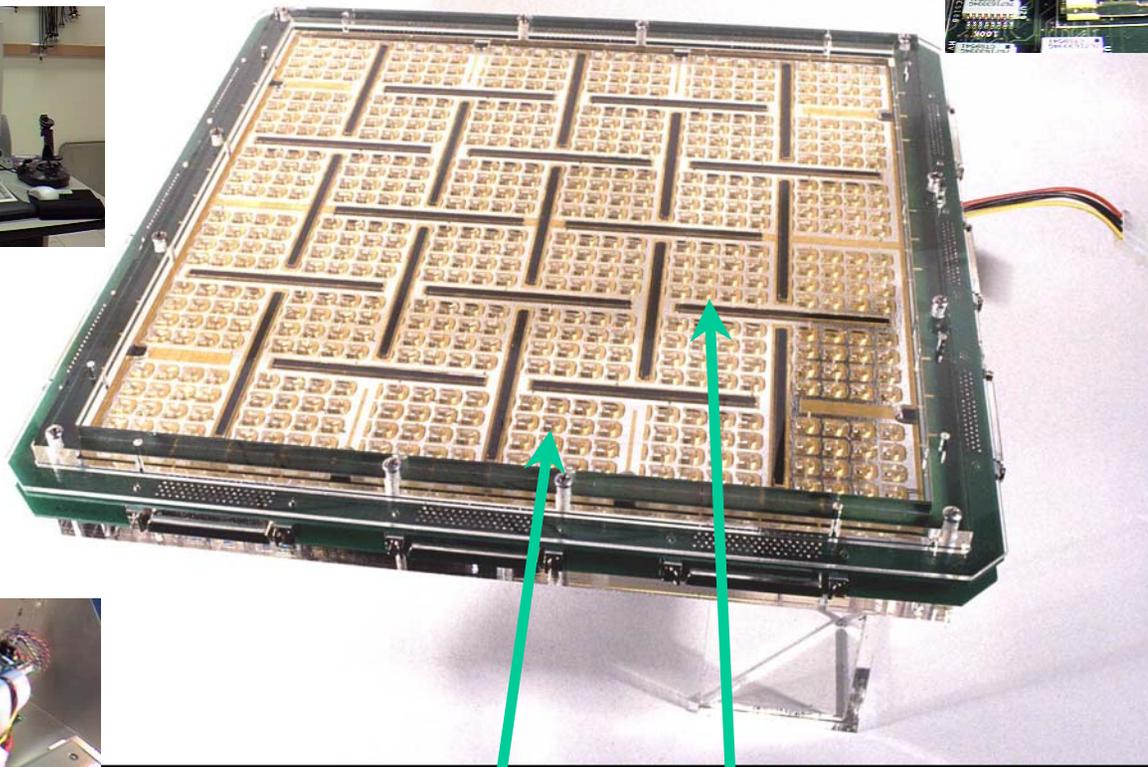
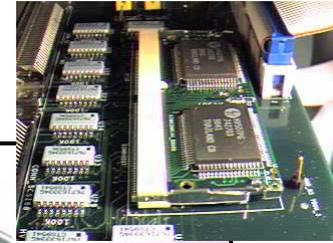
# Levitating Media Transport

- Using large MEMS-like arrays to manipulate macro-scale objects
- Directed air jets as a ‘leverage point’
- 12”x12” array containing 576 individually valved jets and 32,000 photodiode sensors
- Precision motion control: ~50 microns

# MEMS-based Active Surface

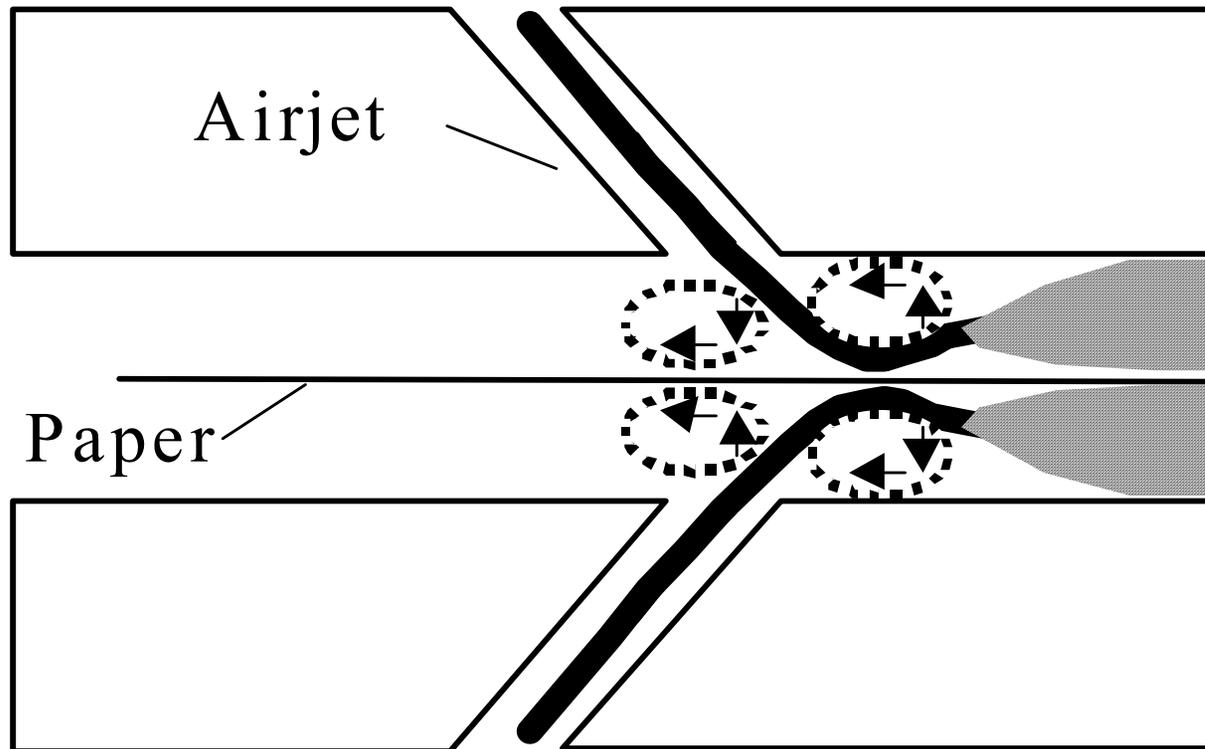
PC-hosted DSP  
control @ 1 kHz

12x12" Board



576 Valves  
(144 per direction)

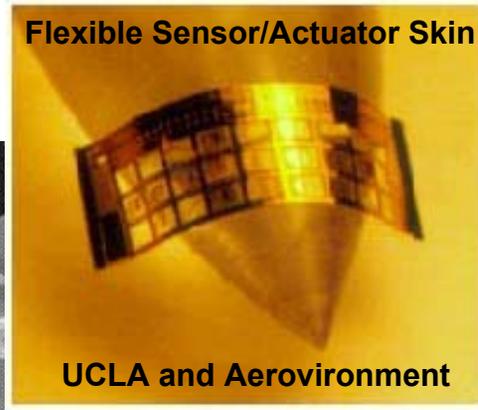
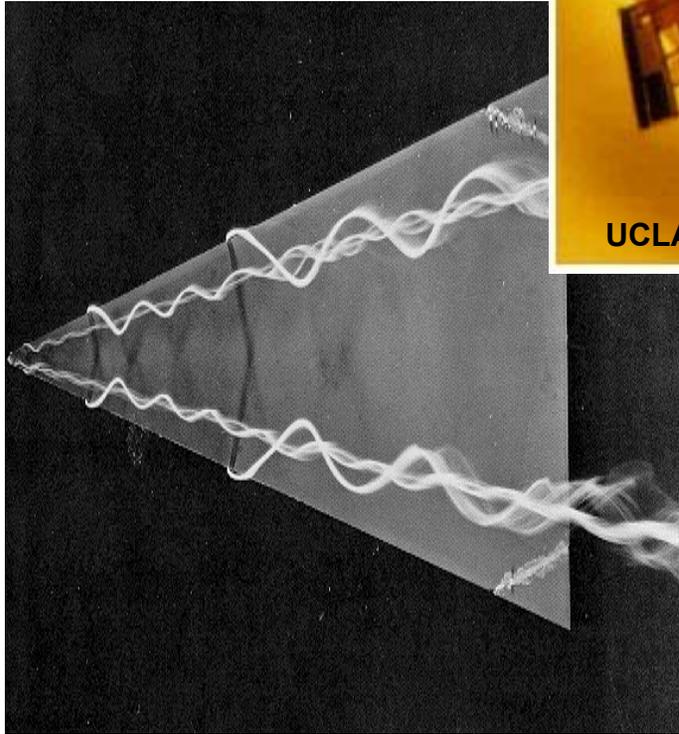
# Air jet actuation



# Airjet Paper Moving

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# MEMS Actuators for Aero Control



**MEMS Actuator Array on the Leading Edge of  
Wing of 1/7 Scale Mirage III Fighter**

*UCLA and Aerovironment*

# Aircraft Controlled by Micro Actuators

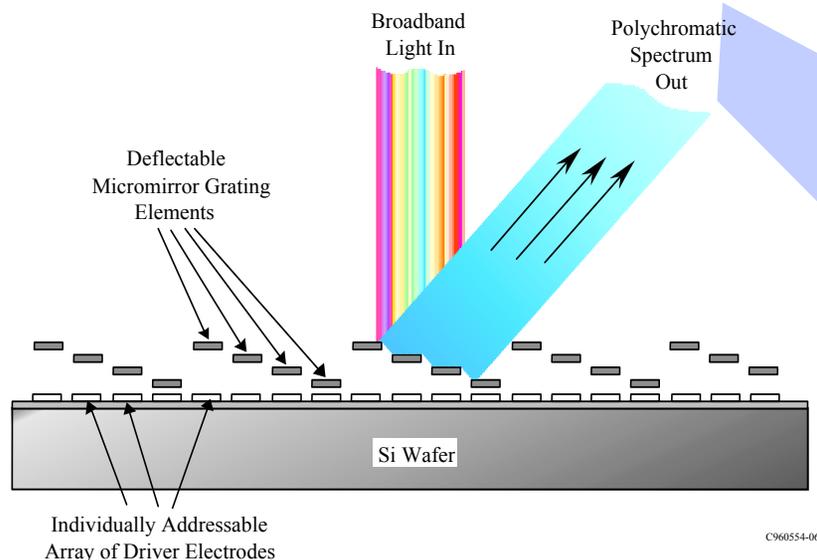
Gwo-Bin Lee & Chih-Ming Ho, UCLA

T. Tsao, F. Jiang & Y. C. Tai, Caltech

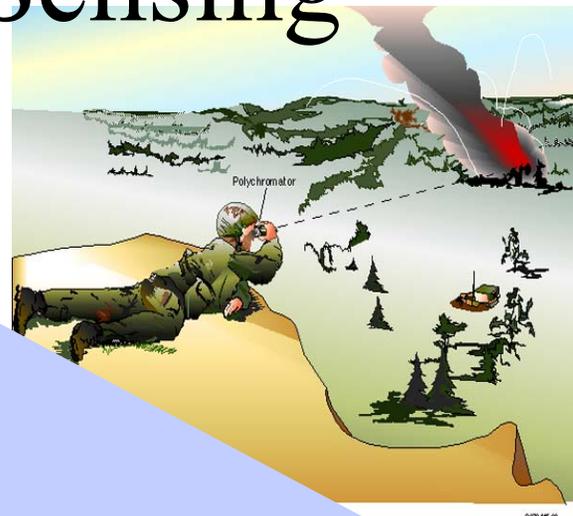
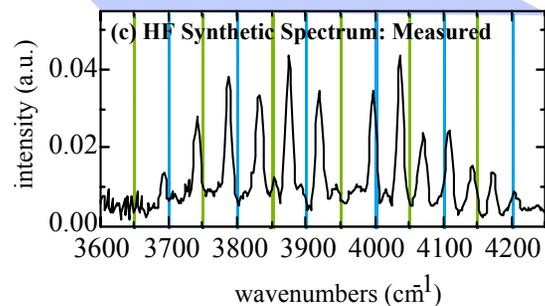


# Standoff Chemical Sensing

## MEMS Polychromator

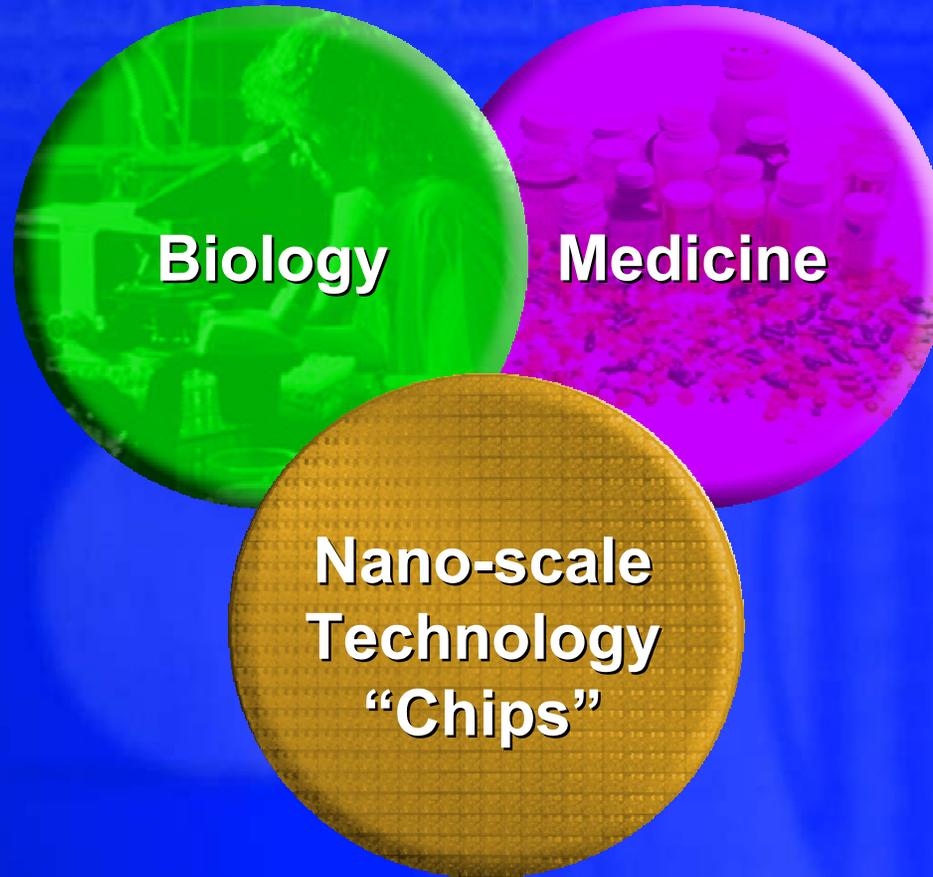


Honeywell Corp.

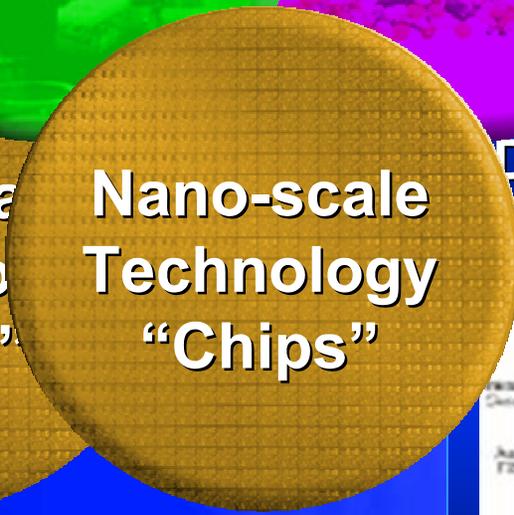
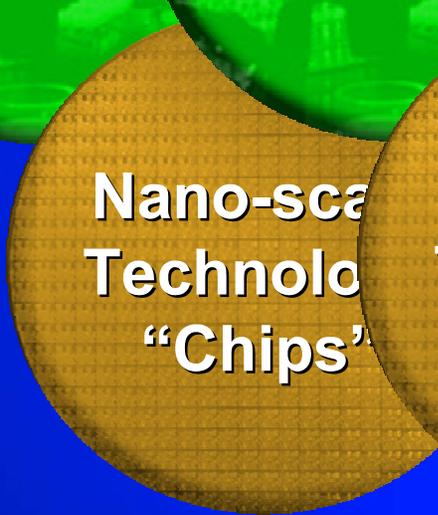
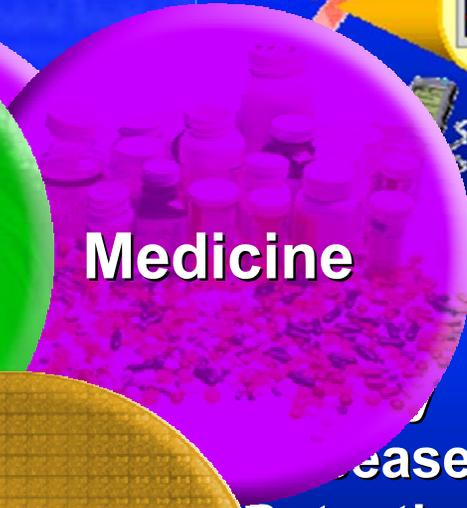
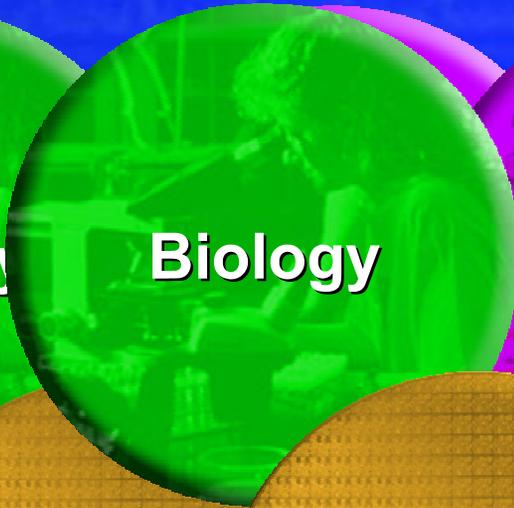


- A new concept for a programmable, dark-field correlation spectrometer based on a MEMS diffraction grating.
- Leads to development of a miniature, programmable remote chemical detection system for field use.

# Converging Technologies: Silicon Meets Biology



# Converging Technologies: Silicon Meets Biology



Bandage

Smart  
Band-aids

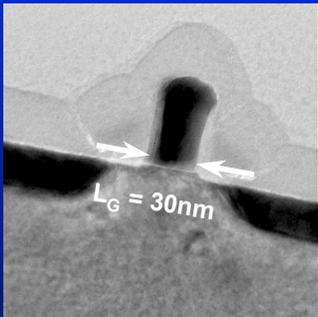
Digital Assistant

Disease  
Detection

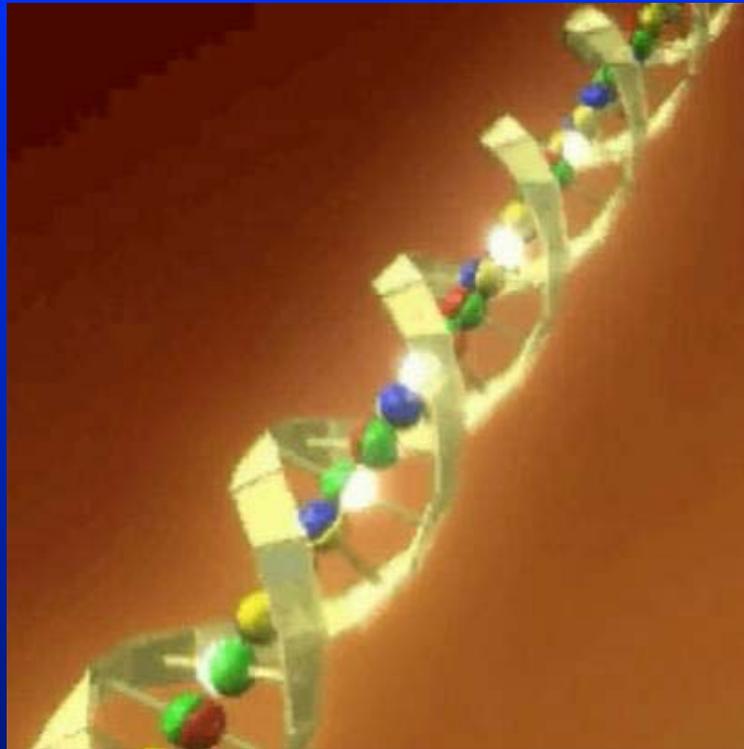
Health  
Monitoring

# Operating At The Nano-scale

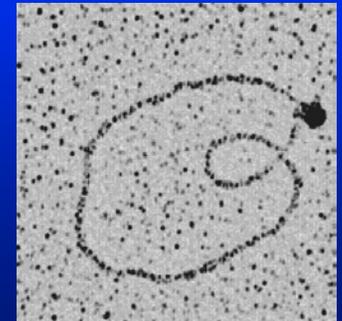
30 Nm Intel  
Research  
Transistor



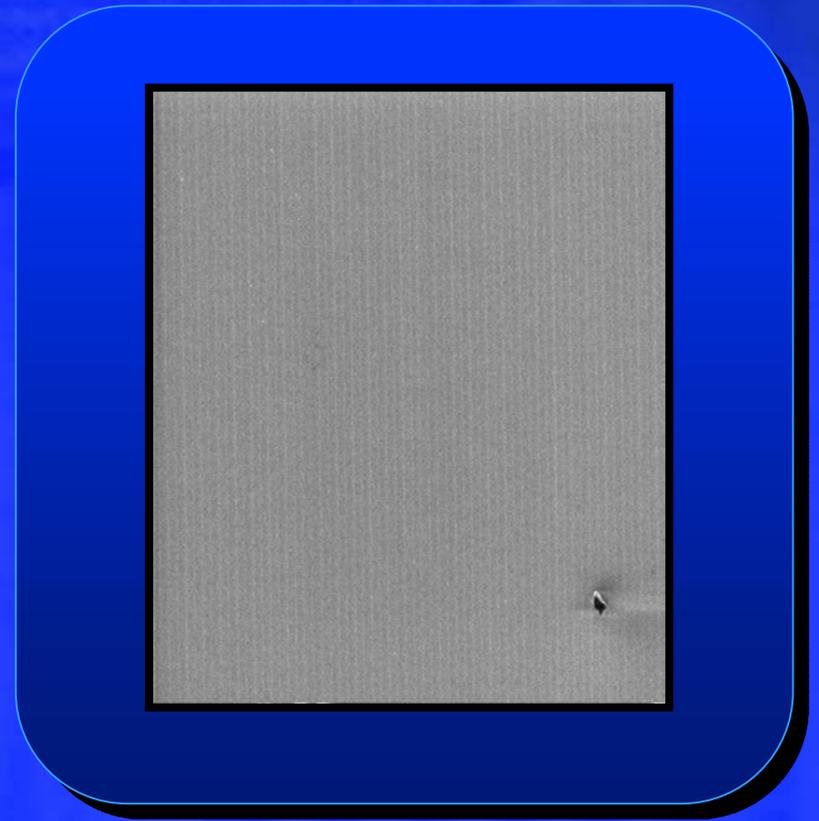
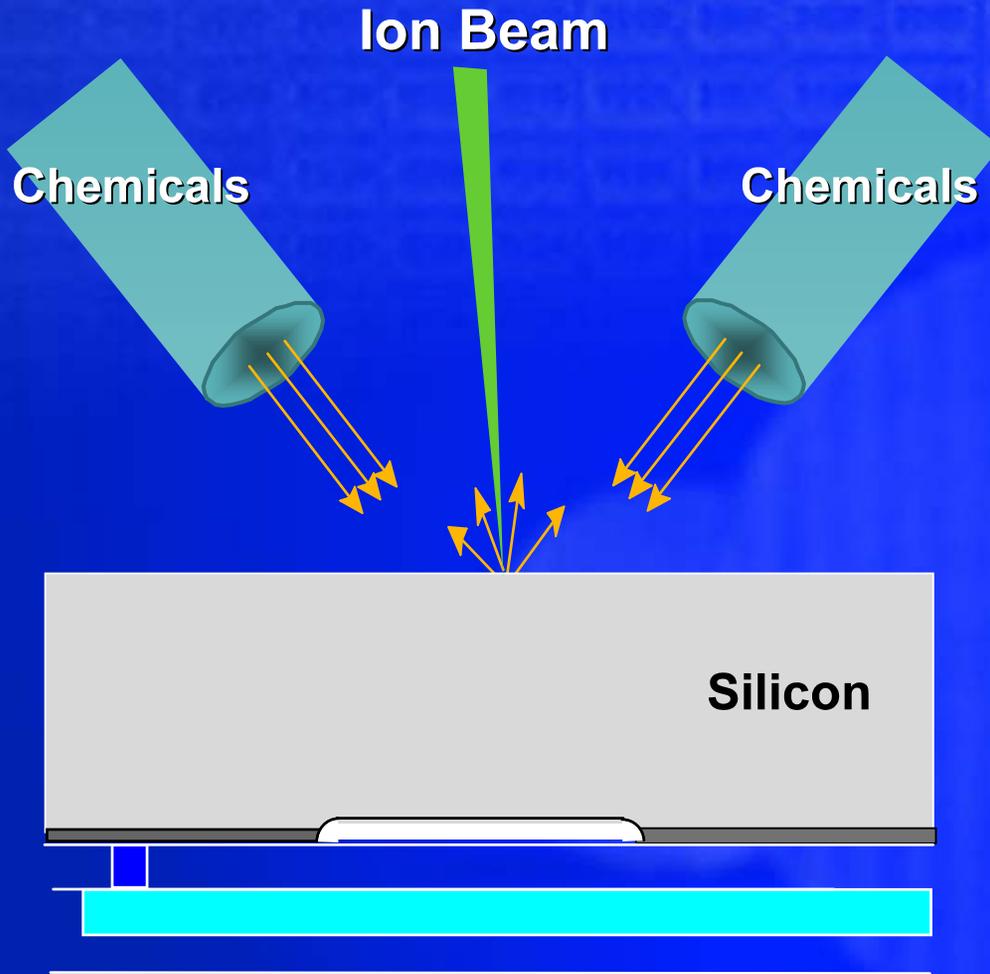
Human DNA



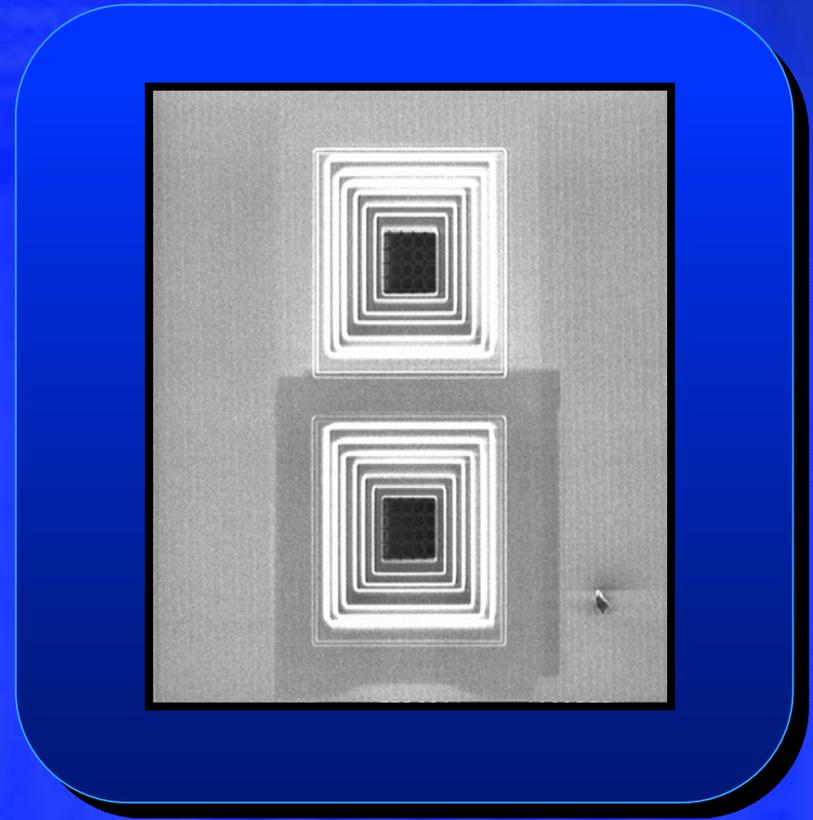
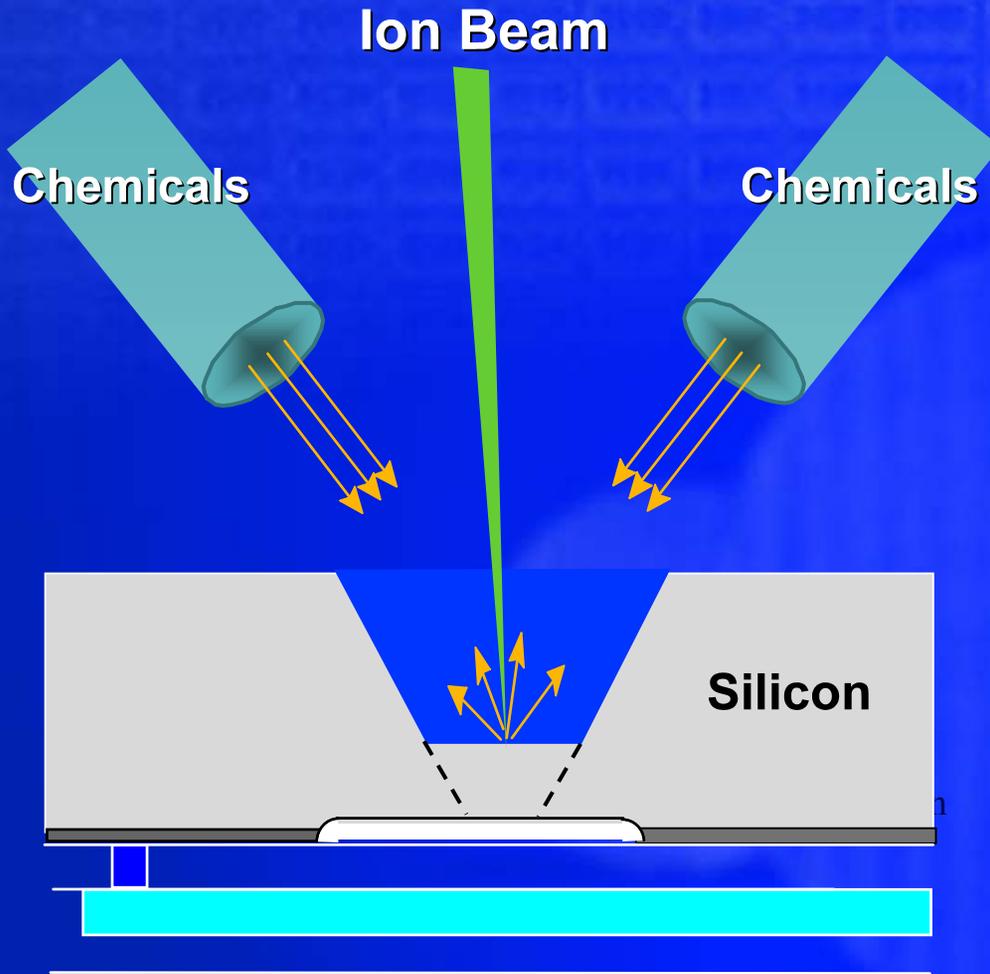
10nm Gold  
Particle with DNA



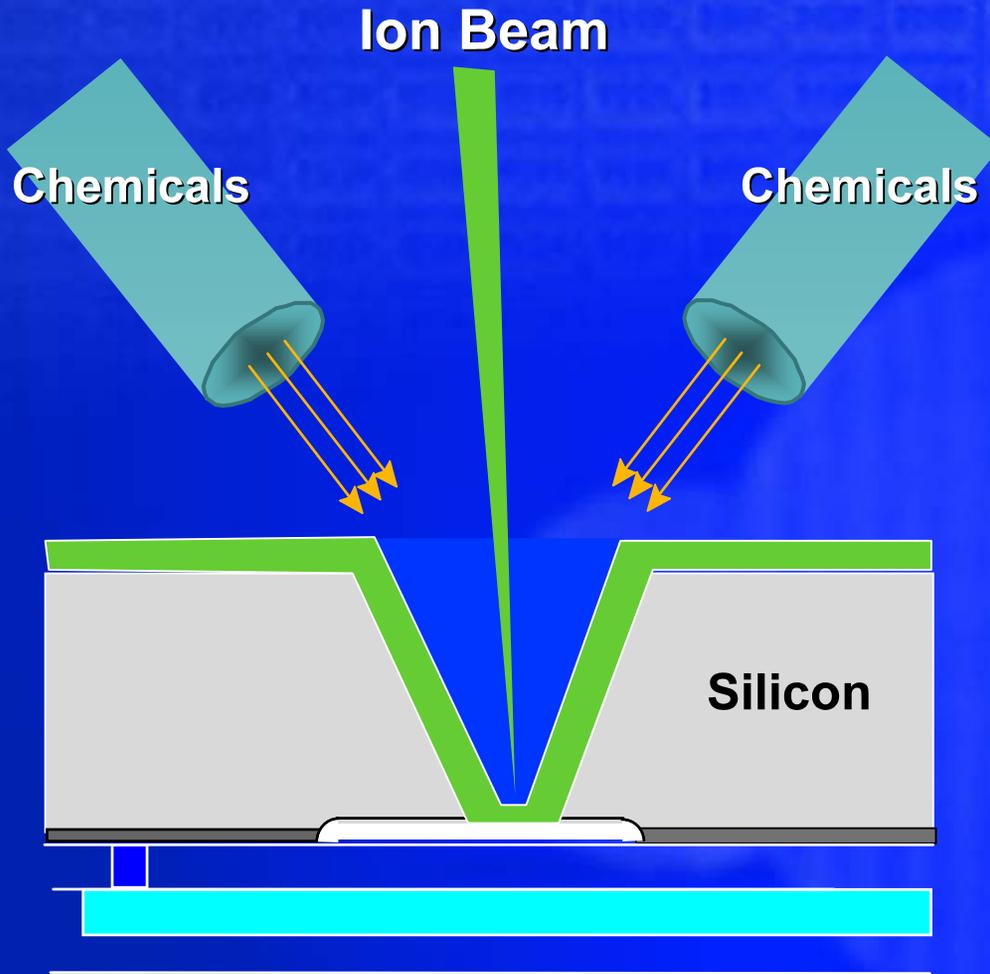
# Sculpting at the Nano-scale



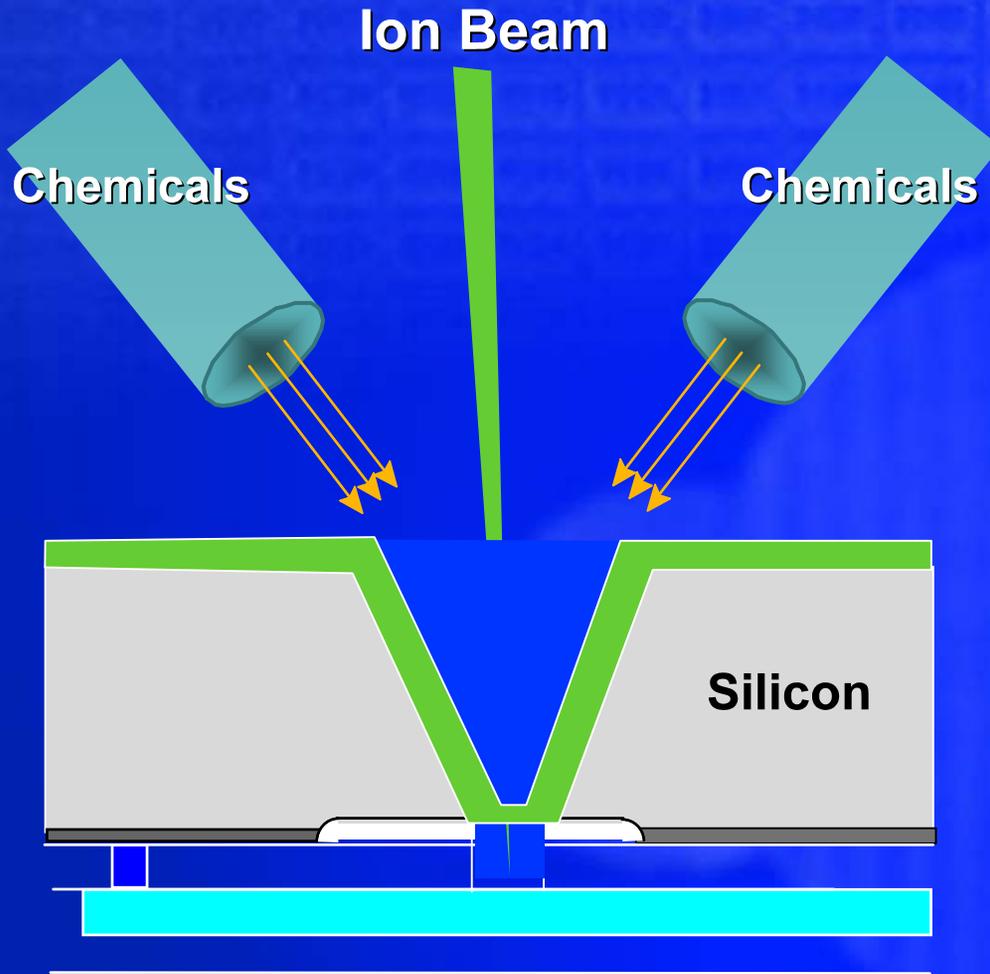
# Sculpting at the Nano-scale



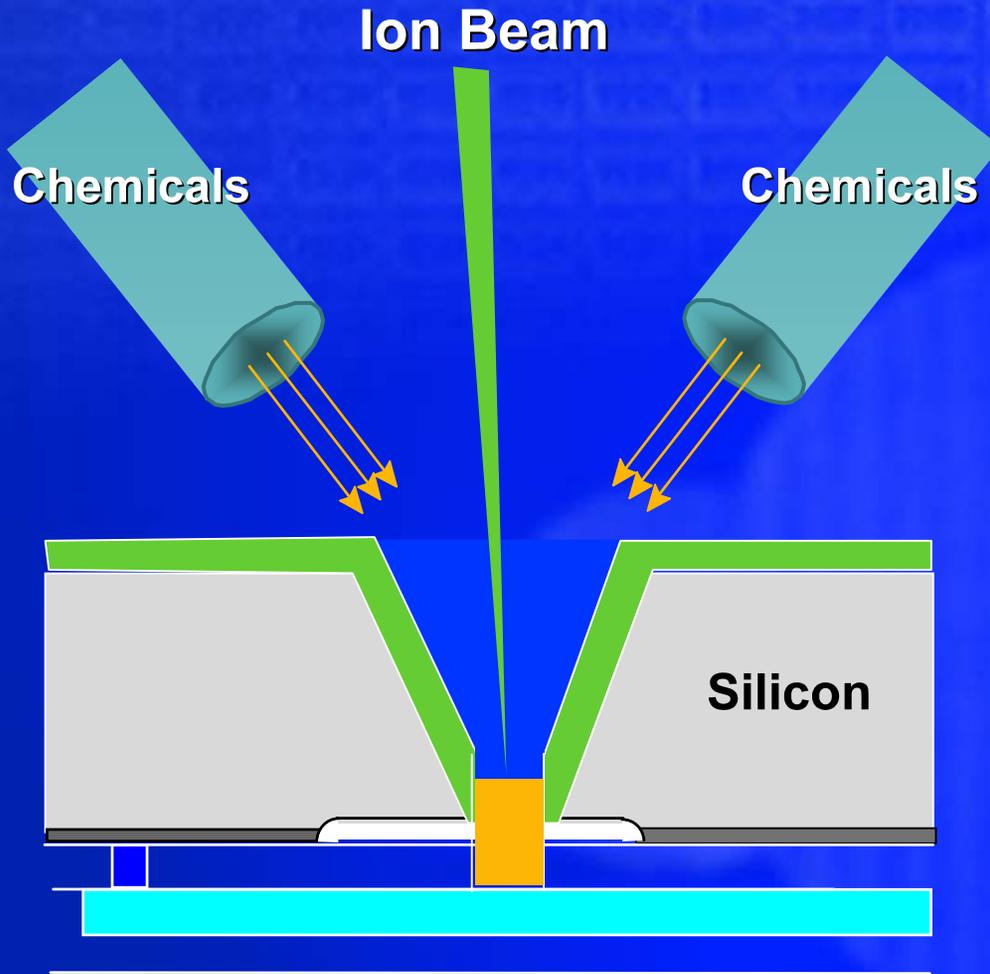
# Sculpting at the Nano-scale



# Sculpting at the Nano-scale

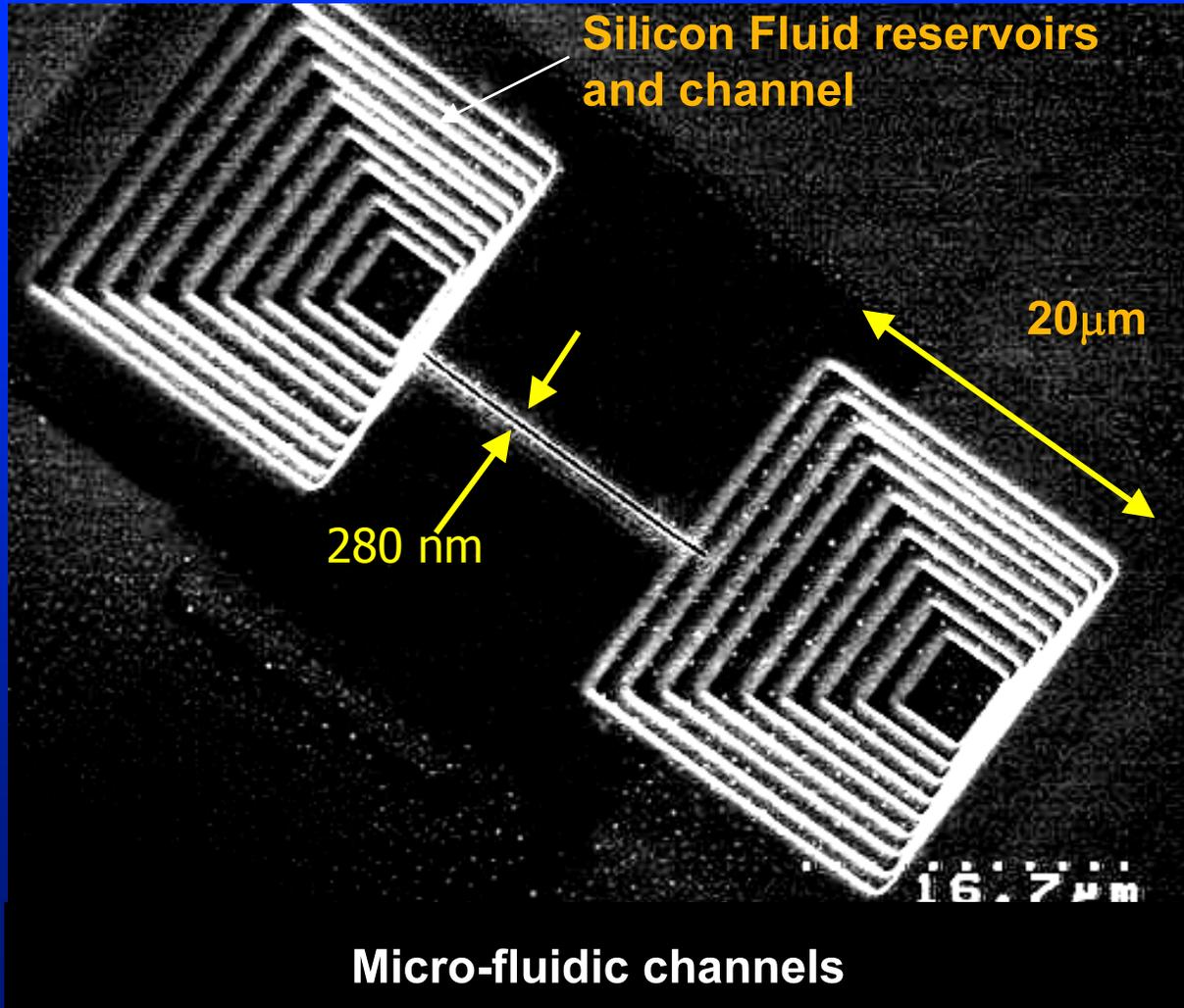


# Sculpting at the Nano-scale

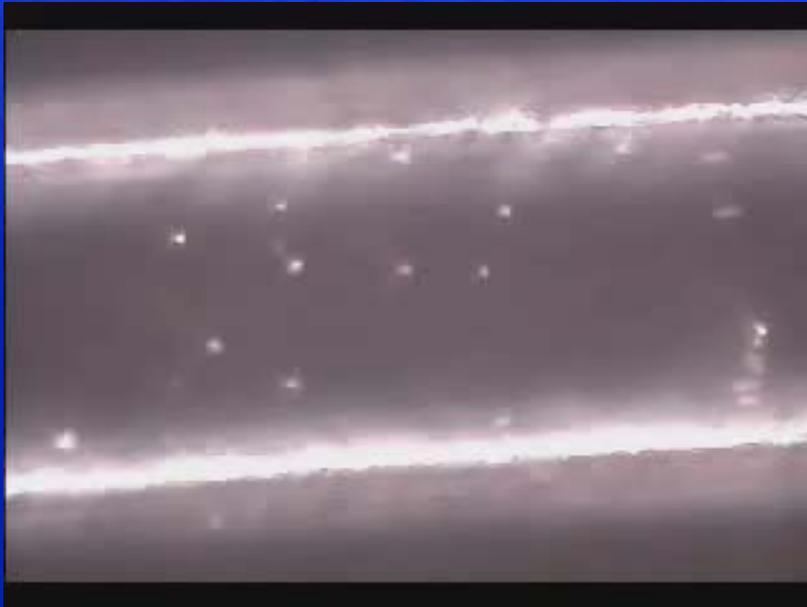


# Research Results

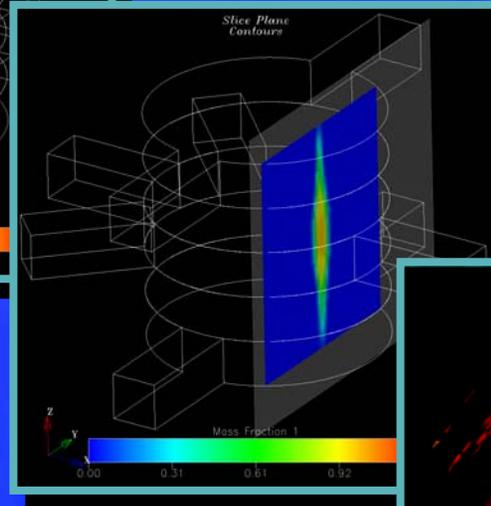
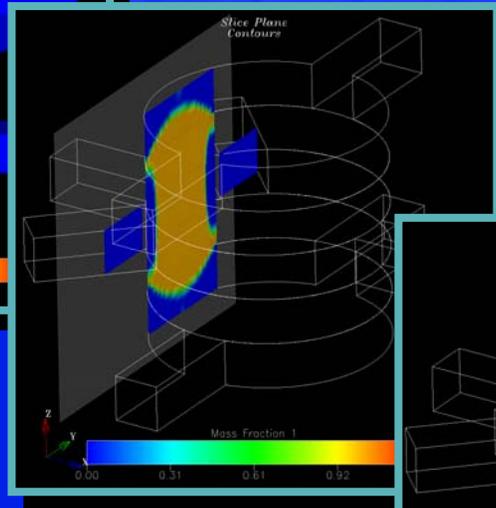
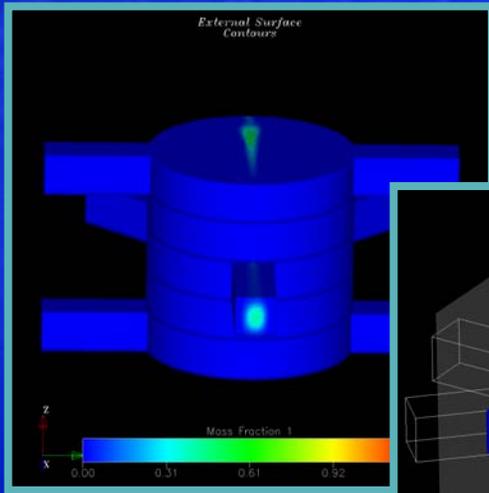
## Early Research: Micro-fluidics



# DNA Flow In Microchannel



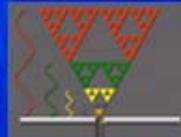
# Intel Precision Biology



Precision Biology Project Produces  
Intel's First Microfluidic Chips

intel

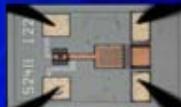
# *MEMS for wireless integration*



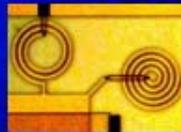
**Antennas**



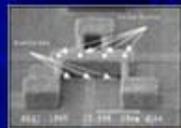
**Color bi-stable display**



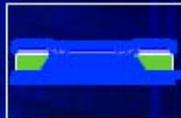
**Micro-switches**



**Tunable capacitors and inductors**

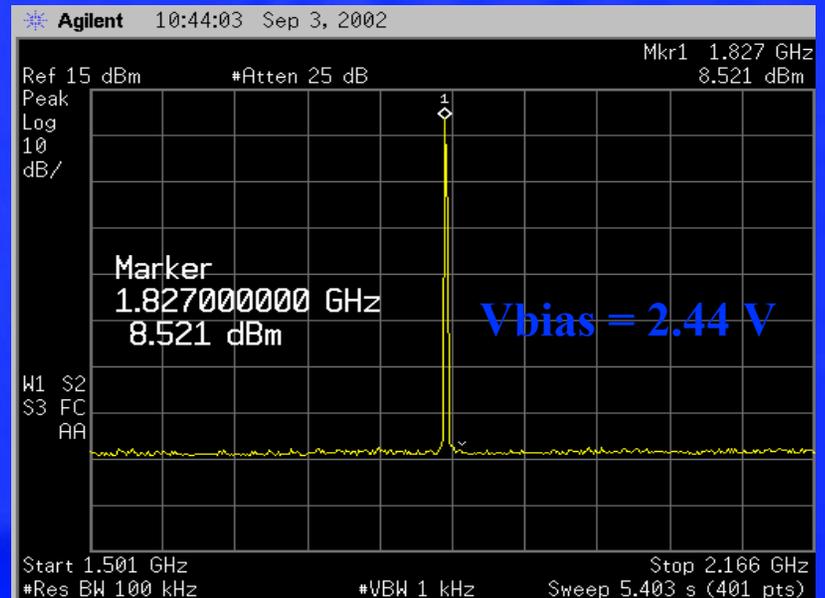
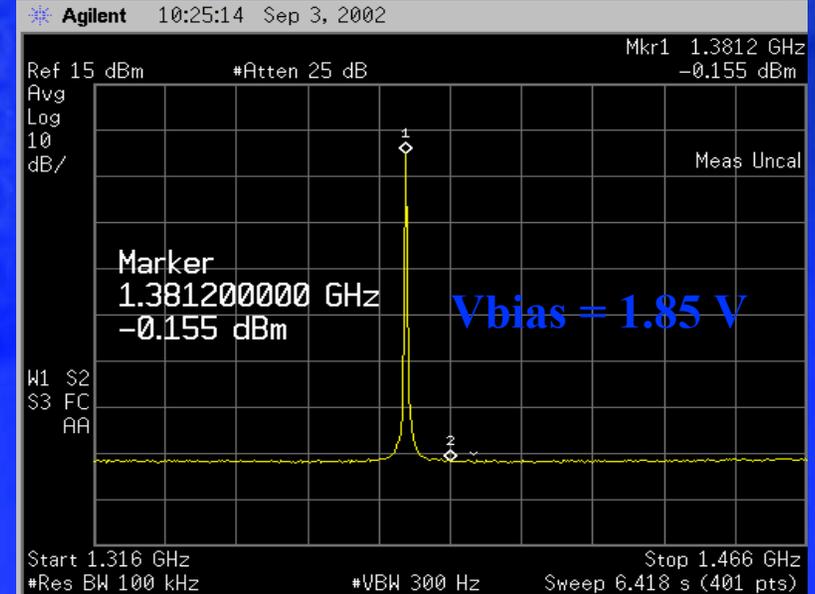
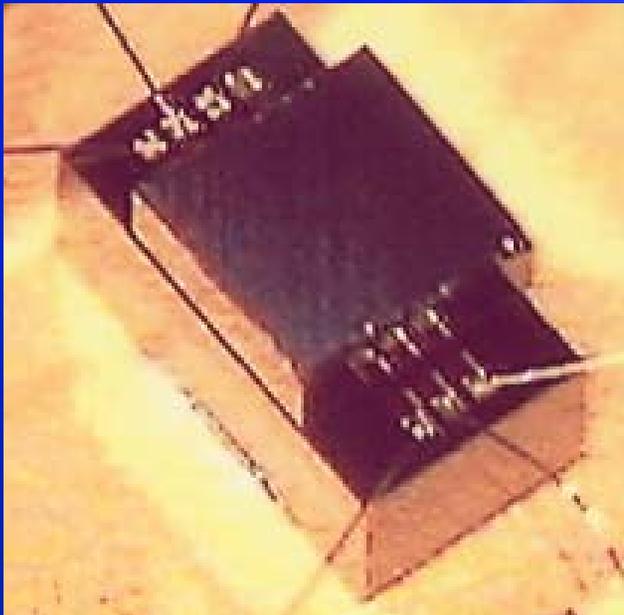
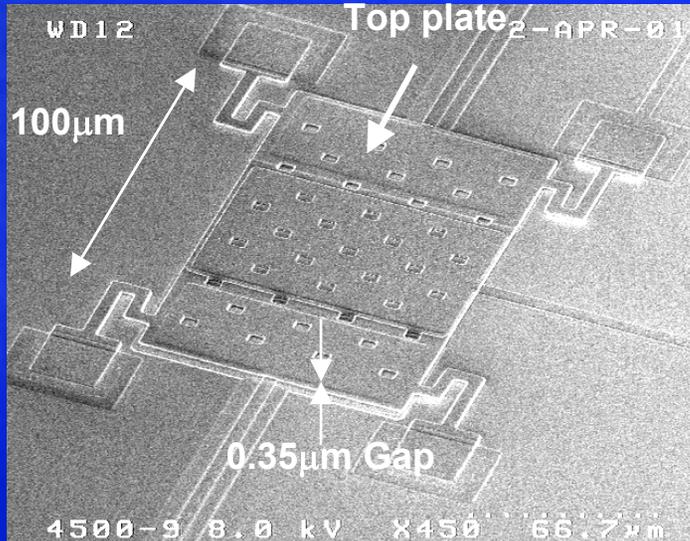


**Tunable filters**



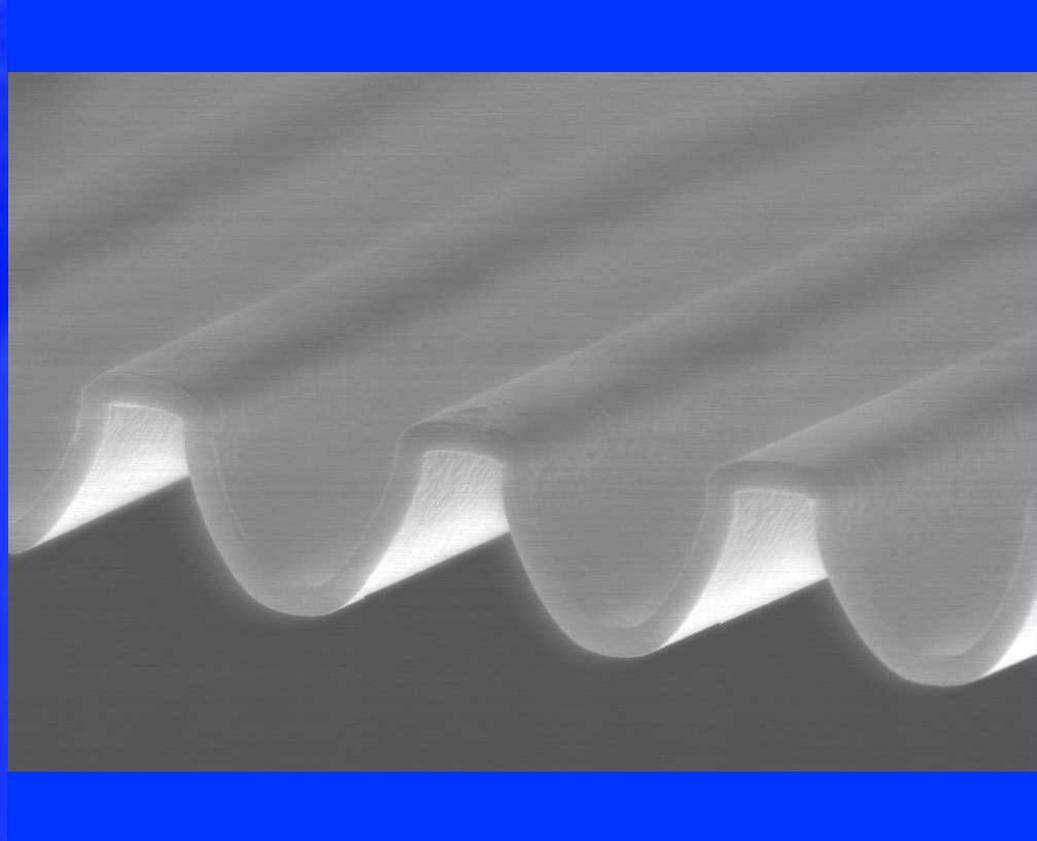
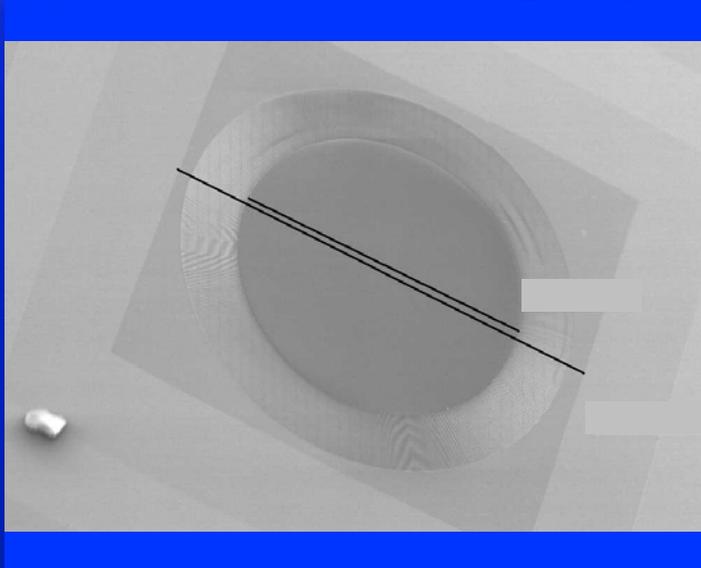
**Directional microphone**

# Aluminum plate varactor and VCO

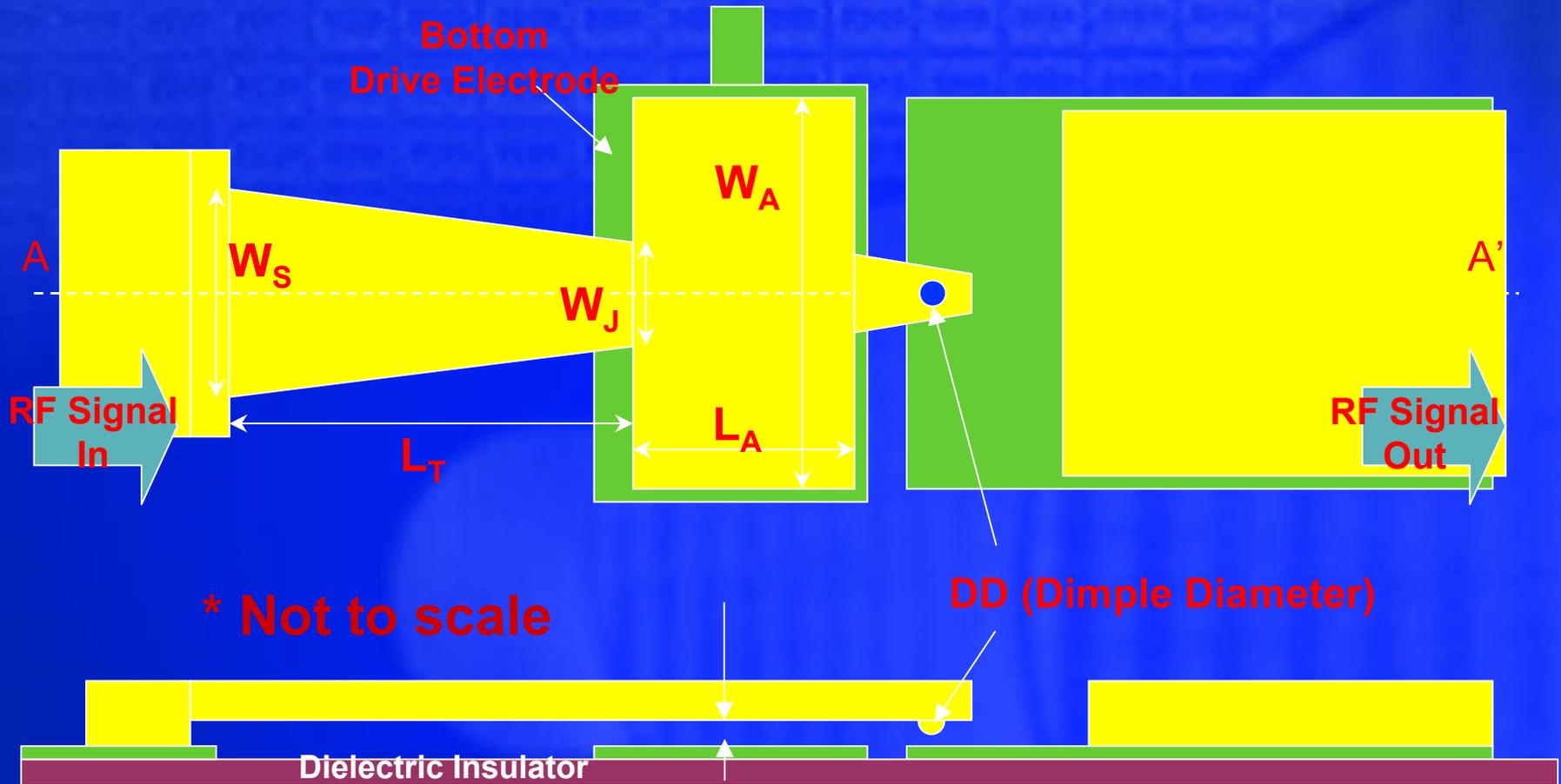


# MEMS Microphone - Corrugated Silicon Nitride Membrane

Top view



# In-line resistive switch

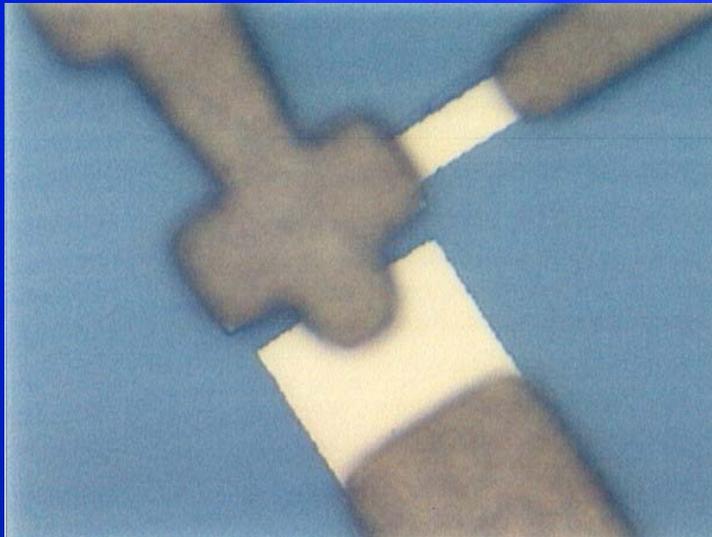
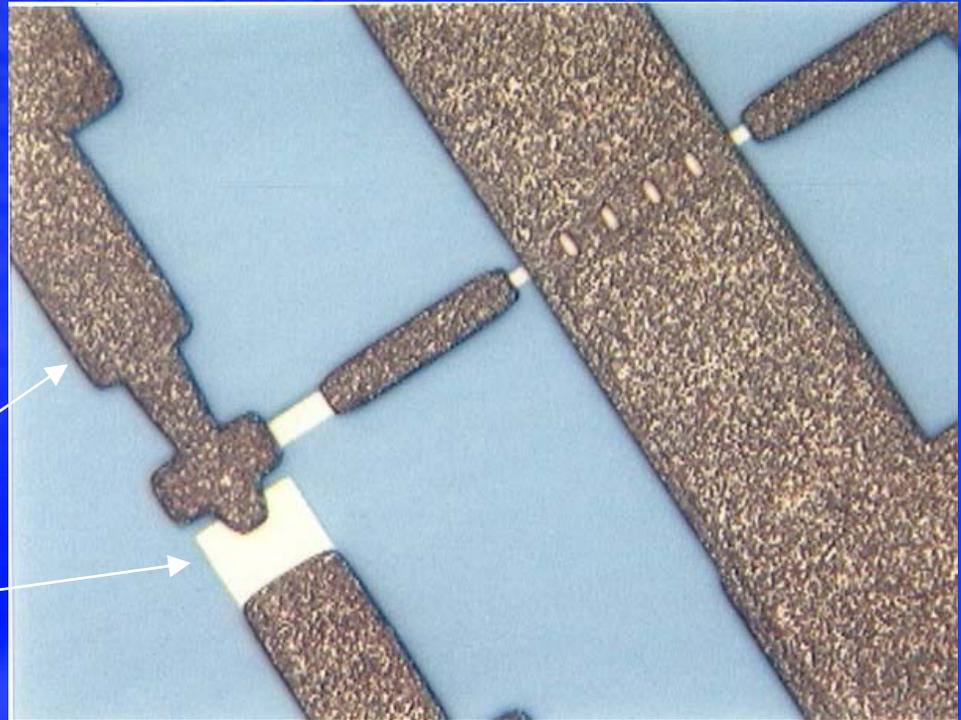


Dimensions optimized using simulation

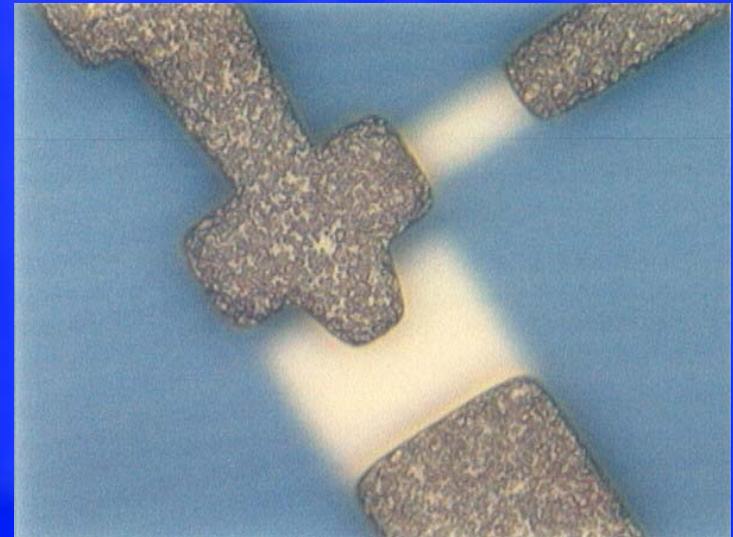
# Released switch

Plated Au

Sputtered Au



Focus on bottom electrode

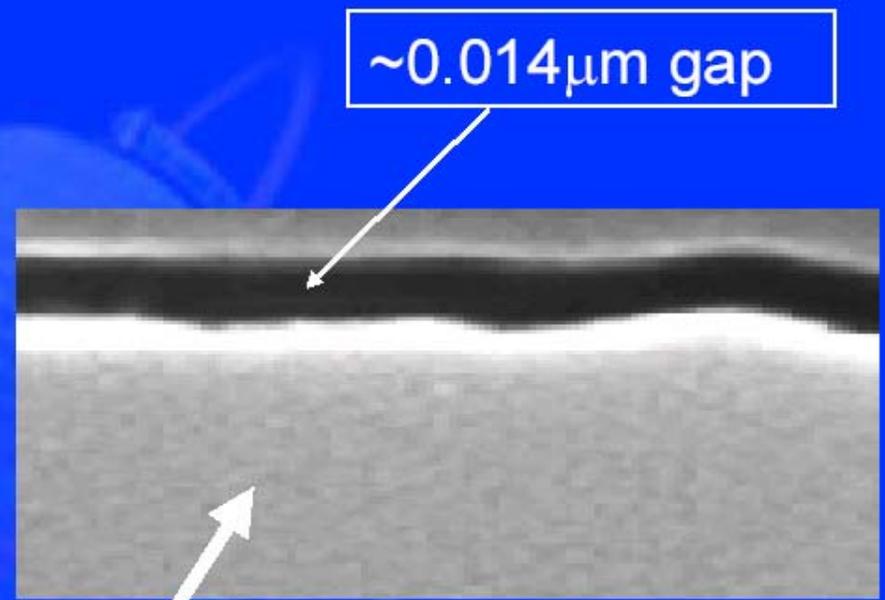


Focus on top electrode

# Call to Action

- **Optimize RF architectures to exploit the full capabilities that MEMS components can provide**
- **Deploy high value MEMS passive components in wireless handsets in the 3-4 year time frame**
- **Evolve tight integration of MEMS, Analog and RF functions in the longer term**

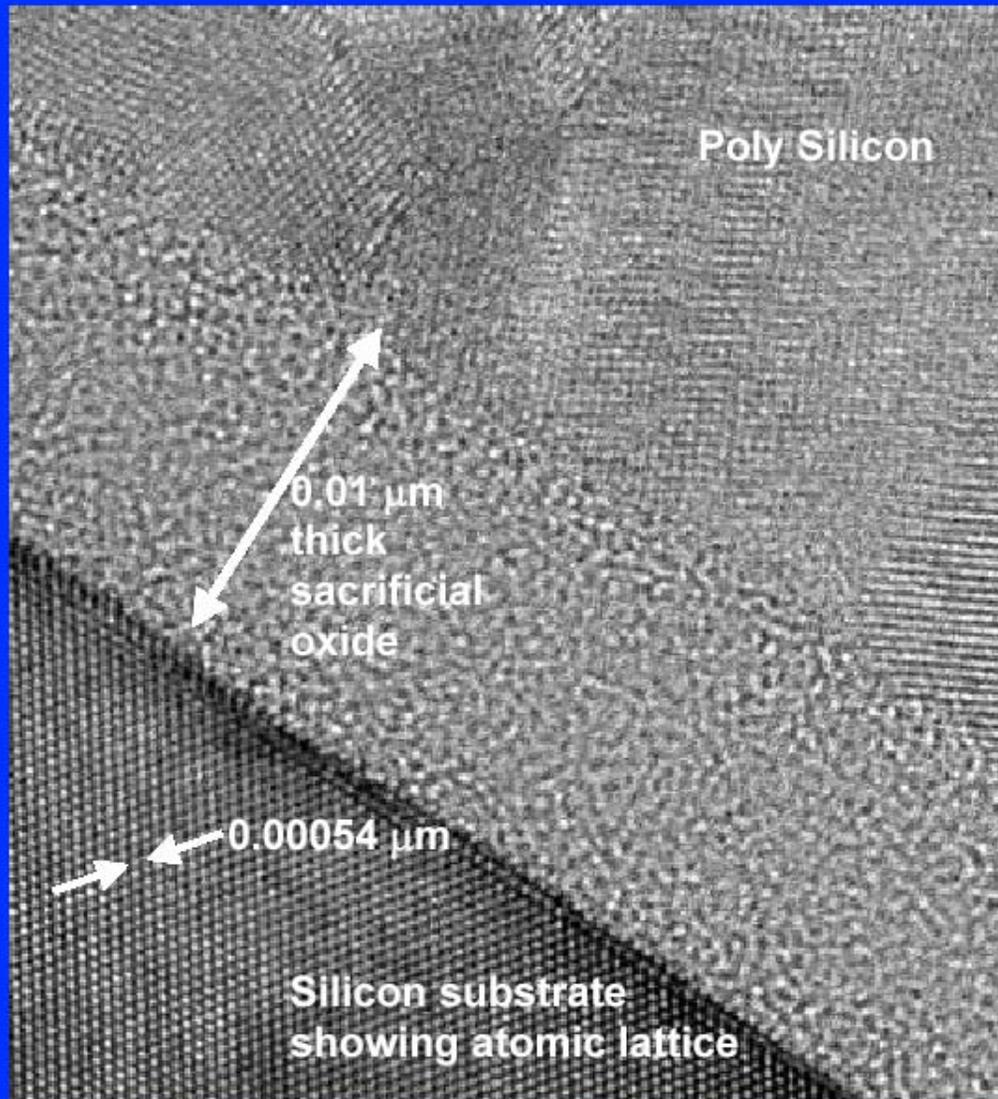
# Beam Resonator with 0.014 $\mu\text{m}$ Gap



Conformal step coverage



# Analytical Capability

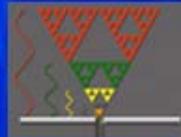


- Intel's Advanced analytical capability enables visualization of nano scale MEMS structures
  - We can see what we have built !
  - Atomic resolution !

# Major MEMS application areas

- Navigation
- Industrial
- Displays
- Optical communications
- **RF (MEMS Radio)**
- **Microbiology meets Microtechnology**
- **MEMS power sources**

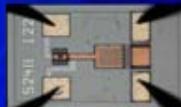
# *MEMS for wireless integration*



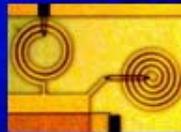
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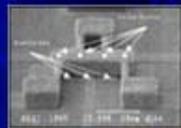
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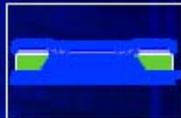
**Micro-switches**



**Tunable capacitors and inductors**



**Tunable filters**



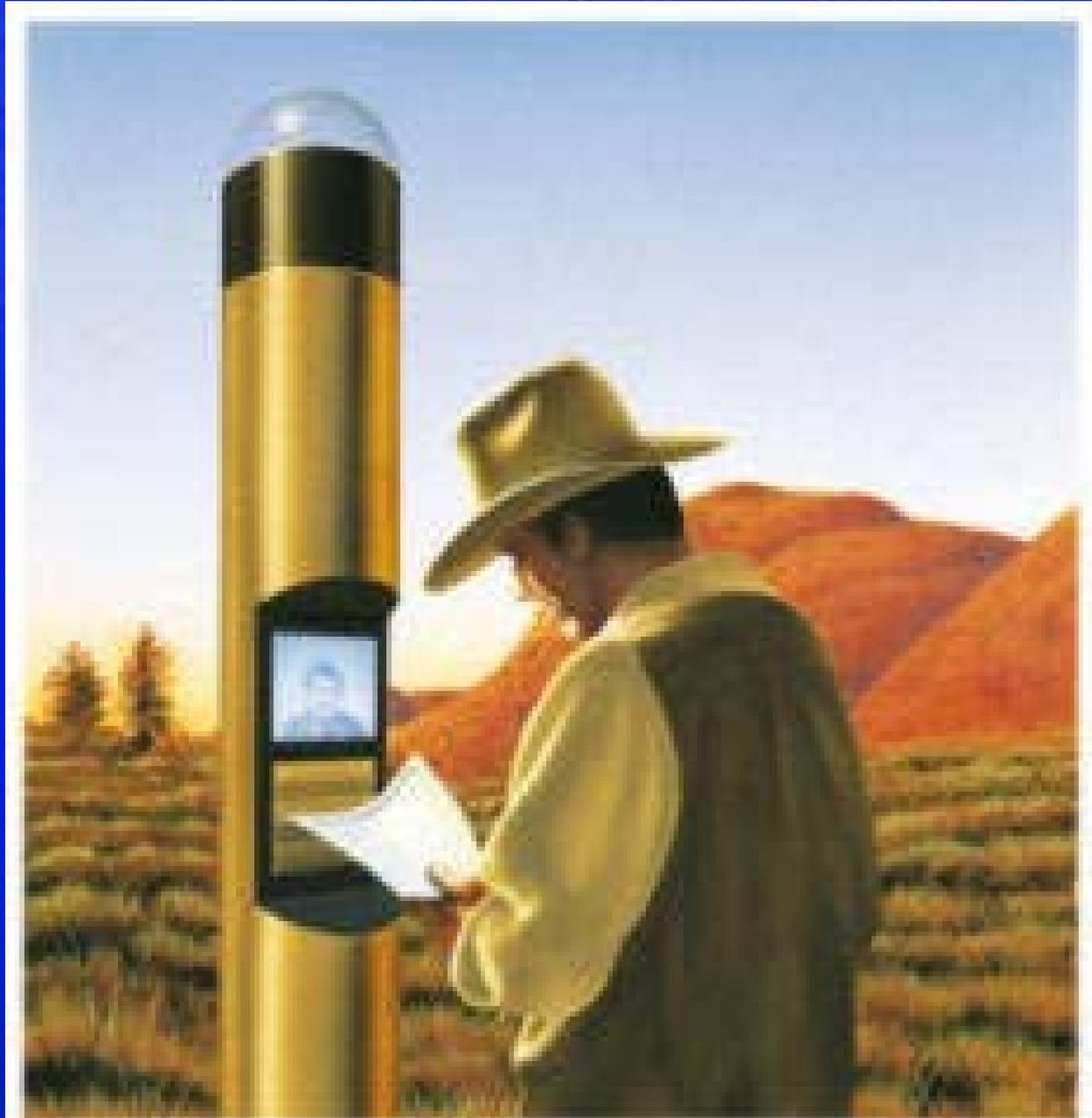
**Directional microphone**

# Wearable Micro-display



Reflector

# How will all this tie together?



intel®

Photo credit:  
Fuji Xerox web site

# Technology and Society Co-Evolve



Telephone switching center, circa 1920

Photo credit: Telephone pioneers archive

# Acknowledgments

This talk is based in part on original material from my Precision Biology lab at Intel, on material from the RF MEMS group at Intel, and in part on material drawn from a MEMS overview slide set prepared by Bill Tang at DARPA, as well as from material created and/or gathered by Kurt Petersen at Cepheid,. Many thanks to Bill and Kurt for providing this material.

Thanks also to Mark Miles at Iridigm, Chih-Ming Ho's group at UCLA, and the air jet paper mover team at the Xerox Palo Alto Research Center for providing slides and presentation material.

Some material is also drawn from a workshop on 'Lifescapes of the Future' that Gitti Jordan and I ran a couple of years ago.